Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/774,039	MIKULA, MITCHELL B.	
Examiner	Art Unit	
Le Nguyen	2174	

SEARCHED					
Class	Subclass	Date	Examiner		
715	734	9/17/2007	LVN		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
			,	
	b, USPAT: /734	9/17/2007	LVN	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
confirmed allowance w/Ba Huynh	9/14/2007	LVN	
IEEE Xplore; ACM Digital Library	9/14/2007	LVN	
EPO, JPO	9/17/2007	LVN	
US-PGPub, USPAT: 715/734,738; 707/200; 711/114	9/17/2007	LVN	
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